

Notice of References Cited	Application/Control No. 10/568,746		Applicant(s)/Patent Under Reexamination TAKI ET AL.	
	Examiner Vivian Chen		Art Unit 1794	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,527,594	06-1996	Kinoshita et al.	428/212
*	B	US-5,662,988	09-1997	Nakayama et al.	428/212
	C	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N	JP 63-267550	11-1988	JP	Nose et al	
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U				
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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